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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: MIZUMURA et al  
Serial No.: 10/080,540  
Filed: February 25, 2002  
For: Etching Method Of Organic Insulating Film  
Art Unit: 1765  
Examiner: S. Ahmed

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 29, 2003

Sir:

This is in response to the Office Action mailed September 25, 2003, in connection with the above-identified application. Amendments to the application are listed below and are set forth on the following pages.

Amendments to the Claims

Remarks are included following the amendments

01/06/2004 HLE333 00000060 10080540

01 FC:1201 86.00 OP  
02 FC:1202 54.00 OP